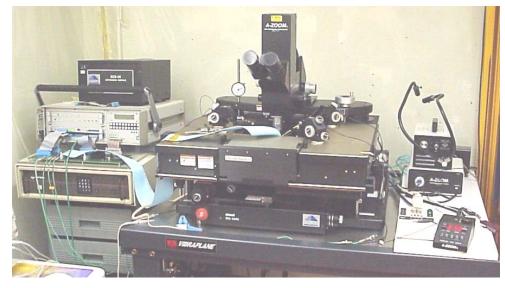
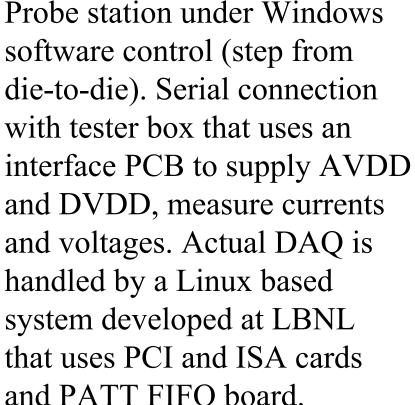


Wafer scale testing of SVX4

W. Wester FNAL

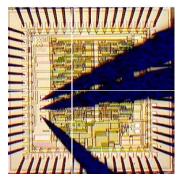
- I. ASIC Testing Lab
- II. SVX4 History
- III. V1 / V2 results
- IV. 2a / 2b checks
- V. 2a /2b probing
- VI. Status and plans











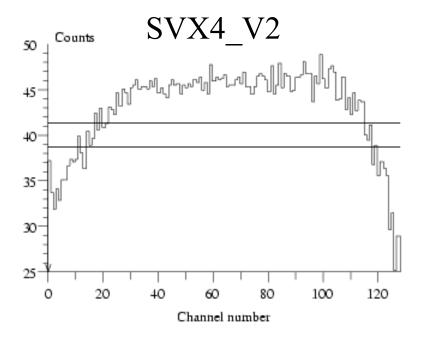
The SVX4 chip for CDF/D0 in Run IIb

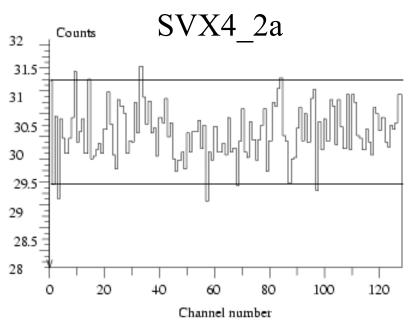
History:

- 2000: Only 0.25 µm makes sense LBNL starts some design
- 2001: Official FNAL/LBNL project
- 2001: SVX4FE FNAL front-end test chip works!
- 5/2002: SVX4_V1 and SVX4_V2 full-size prototypes work well. 97% of the parts are functional. 91% appear perfect (very high yield). Parts used for hybrid and stave prototypes.
- 5/2003: SVX4_V2a (back-up), SVX4_V2b (pre-production, but it's likely the production chip). Initial tests show high yields.

SVX4_V1 and V2 wafer probing

- 12 wafers total, 9 with probing results
 - (2 diced before tests, 1 with some suspect results)
- 9 wafers probed for current measurements
 - 18/936 chips fail with bad current draw on either AVDD or DVDD (i.e. shorts) (1.9%)
- ~7 wafers probed for basic functionality
 - 37/762 chips have a small problem (bad channel(s), fail sparsification, etc.) (4.3%)
- 3 V2 wafers tested fully (all pipeline cells etc.)
 - 4/156 chips have a very small problem (more than one bad pipeline cell, noisy, etc.) (2.6%)
- Overall yield: 91.2% perfect, 97% functional!

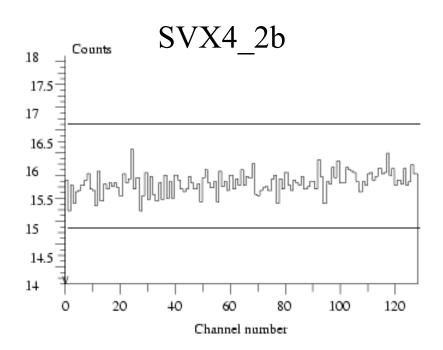


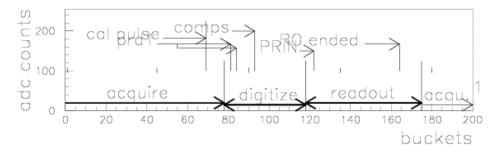


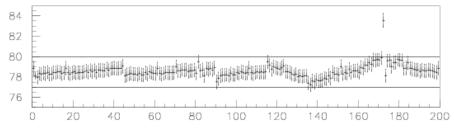
Extreme settings to highlight the bow: Minimize time between Comp and ramp resets

Ramp Ped set to max (lowest pedestal) or 9 for _V2 and 10 for _2x DVDD = 2.75 V (AVDD = 2.5 V)

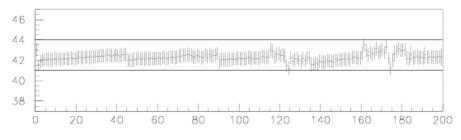
Offset of 15 cnts between _2a and _2b exists for other ramp ped settings.



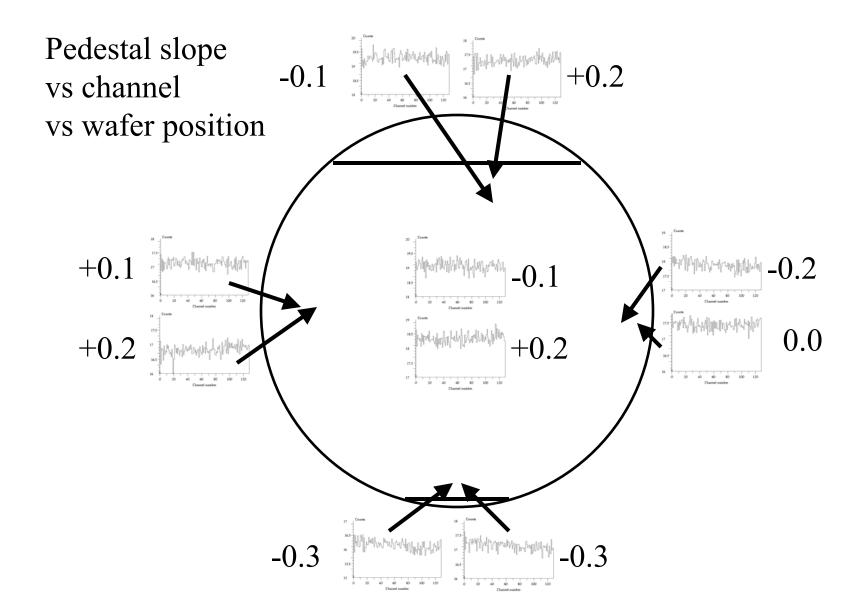




Pedestal vs pipeline cell for a single channel during various operations. SVX4_V2 (older version) compared with SVX4_2b (newer version). small slope over 46 pipeline cells is observed. Small coupling of chip operation into pedestal readout.



SVX4 2b



SVX4_2a and _2b wafer probing

- 11/11 initial devices looked good (basic functionality) before grinding and plating
- 56 devices looked at after grind/plating
 - 2 bad (current draws)
 - 10 with one or two bad channels
 - 4 with higher pedestal (needs investigation)
- Note: many of the 56 devices were close to the wafer's edge

SVX4_2a SVX4_2b wafer probing results

- 7/8 of the 1st wafer tested (398 devices)
- A 2nd wafer probed (454 devices)
- Only 4 devices found non-functional
 - 2 bad current draws
 - 2 bad readout
- Next to examine:
 - Bad channels
 - Bad pipeline cells